



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TANIGUCHI

Atty. Ref.: 972-85

Appl. No. 09/941,668

Group: 2851

Filed: August 30, 2001

Examiner: H. Nguyen

For: PROJECTION EXPOSURE APPARATUS AND METHOD

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July 17, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In response to the Office Action dated March 19, 2003, the period for response having been extended one month by petition herewith, please amend the above-identified patent application as follows:

07/16/2003 SDIRETA1 00000007 09941668

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110.00 DP

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